



Image

Patent
Attorney Docket No. 018765-177

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of
Yoshihisa Saimoto et al.

Application No.: 10/506,806

Filing Date: September 7, 2004

Group Art Unit: 2811

Examiner:

Confirmation No.: 5415

Title: PRESSURE SENSITIVE ADHESIVE FILM FOR PROTECTION OF SEMICONDUCTOR WAFER
SURFACE AND METHOD OF PROTECTING SEMICONDUCTOR WAFER WITH THE PRESSURE
SENSITIVE ADHESIVE FILM

SECOND
INFORMATION DISCLOSURE STATEMENT
TRANSMITTAL LETTER

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

Enclosed is a **SECOND** Information Disclosure Statement and accompanying form
PTO-1449 for the above-identified patent application.

- ☒ No additional fee for submission of an IDS is required.
- ☐ The fee of \$180.00 (1806) as set forth in 37 C.F.R. § 1.17(p) is also enclosed.
- ☐ A statement under 37 C.F.R. § 1.97(e) is also enclosed.
- ☐ A statement under 37 C.F.R. § 1.97(e), and the fee of \$180.00 (1806) as set forth in 37 C.F.R. § 1.17(p) are also enclosed.
- ☐ Charge _____ to Deposit Account No. 02-4800 for the fee due.
- ☐ A check in the amount of _____ is enclosed for the fee due.
- ☐ Charge _____ to credit card. Form PTO-2038 is attached.

The Director is hereby authorized to charge any appropriate fees under 37 C.F.R. §§ 1.16, 1.17 and 1.21 that may be required by this paper, and to credit any overpayment, to Deposit Account No. 02-4800. This paper is submitted in duplicate.

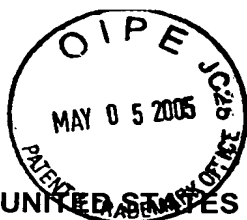
Respectfully submitted,

BURNS, DOANE, SWECKER & MATHIS, L.L.P.

P.O. Box 1404
Alexandria, Virginia 22313-1404
(703) 836-6620

By Robert G. Mukai
Robert G. Mukai
Registration No. 28,531

Date: May 5, 2005



Attorney's Docket No. 018765-177

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of)
Yoshihisa Saimoto et al.) Group Art Unit: 2811
Application No.: 10/506,806) Examiner:
Filed: September 7, 2004) Confirmation No.: 5415
For: PRESSURE SENSITIVE ADHESIVE FILM)
FOR PROTECTION OF SEMICONDUCTOR)
WAFER SURFACE AND METHOD OF)
PROTECTING SEMICONDUCTOR WAFER)
WITH THE PRESSURE SENSITIVE)
ADHESIVE FILM)

SECOND INFORMATION DISCLOSURE STATEMENT

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

In accordance with the duty of disclosure as set forth in 37 C.F.R. § 1.56, the accompanying information is being submitted in accordance with 37 C.F.R. §§ 1.97 and 1.98.

Two of the Japanese documents were previously made of record in the file of the above-identified application in the Information Disclosure Statement filed September 7, 2004. However, the undersigned attorney has now been provided with machine translations of these two Japanese patent documents and such documents are being provided herewith and are being listed on the attached PTO Form 1449.

The Examiner is requested to consider the Report and the cited documents and return the initialed Form 1449 to the undersigned attorney.

Respectfully submitted,

BURNS, DOANE, SWECKER & MATHIS, L.L.P.

Date May 5, 2005

By: Robert G. Mukai
Robert G. Mukai
Registration No. 28,531

P.O. Box 1404
Alexandria, Virginia 22313-1404
(703) 836-6620

[illegible][illegible]

NON-PATENT LITERATURE DOCUMENTS	
Examiner Initials	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published.
	English translation of JP 2002-053819 published 02-19-2002.*
	English translation of JP 10-242086 published 09-11-1998.*

Examiner Signature		Date Considered	
-----------------------	--	--------------------	--

*EXAMINER: Initial if reference considered, whether or not citation is in conformance with M.P.E.P. § 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to Applicant.